



ITL

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Achintya K. Bhowmik

Serial No.: 10/814,402

Filed: March 31, 2004

For: Single Crystal Electro-Optic  
Film on Silicon Imager

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Art Unit: 2873

Examiner: Jessica T. Stultz

Docket: ITL.1099US  
P18549

Assignee: Intel Corporation

Mail Stop **Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**REPLY TO OFFICE ACTION**

Sir:

In response to the office action mailed June 19, 2006, please amend the above-referenced patent application as follows:

Date of Deposit: August 21, 2006

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

*Cynthia L. Hayden*  
Cynthia L. Hayden